

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of: **SINGH et al.**

Appln No.: **10/082,010** Examiner: **ANGADI, Maki A.**

Date Filed: **February 22, 2002** Group: **1765**

Att'y Docket #: **5853-224**

For: **SLURRY AND METHOD FOR CHEMICAL MECHANICAL POLISHING
OF METAL STRUCTURES INCLUDING REFRACTORY METAL
BASED BARRIER LAYERS**

REPLY TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

These amendments and remarks are being filed in response to the final Office Action mailed June 24, 2008, and is accompanied by a Request for Continued Examination (RCE). The Commissioner is here by authorized to charge the \$405 fee for a RCE to Deposit Account No. 50-0951. Although no additional fees are believed due, the Commissioner is hereby authorized to charge any deficiency or credit any surplus to Deposit Account No. 50-0951. Please amend the above-identified application as follows:

Amendments to the Claims are contained in the complete claim listing which appears on pages 2-6 of this document.

Remarks/arguments begin on page 8 of this document.